

Form PTO-1449  <b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)		ATTY DOCKET NO. 32860-000901/US	APPLICATION NO. NEW APPLICATION			
		APPLICANT(S) Dr. Walter GUMBRECHT et al.	CONF. NO. Unknown <b>10/539817</b>			
		FILING DATE June 20, 2005	GROUP Unknown			
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
/L.E./	US 2004/063152 A1	04-01-2004	GUMBRECHT et al.			
/L.E./	US 2002/0028441 A1	03-07-2002	HINTSCHE et al.			
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
						YES
/L.E./	WO 00/62047	10-19-2000	WIPO			Abstract
/L.E./	WO 9012314	10-18-1990	WIPO			Abstract
/L.E./	WO 00/63682	10-26-2000	WIPO			X
/L.E./	WO 0242759 A1	05-30-2002	WIPO			Abstract
/L.E./	DE 19610115	09-18-1997	GERMANY			Abstract
/L.E./	DE 10015816	10-18-2001	GERMANY			Abstract
/L.E./	WO 98/19153	05-07-1998	WIPO			X
<b>OTHER DOCUMENTS</b> (Include Name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.) date, page(s), volume-issue number(s), publisher, city and/or country where published.)						
/L.E./	M. Paeschke et al.: Voltammetric Multichannel Measurements Using Silicon Fabricated Microelectrode Arrays, <i>Electroanalysis</i> 8, No. 10, S. 891-899, 1996					
/L.E./	R. Hintsche et al.: Microbiosensors Using electrodes Made in Si-Technology, <i>Frontiers in Biosensorics, Fundamental Aspects</i> , edited by F.W. Scheller et al., Dirk Hauser Verlag, Basel, S. 267-283, 1997					
/L.E./	German Translation Aid Date Unknown					
/L.E./	German Office Action Dated 03-24-2005					
/L.E./	International Search Reports (English and German) dated 05-05-2004					
EXAMINER	/Lydia Edwards/	DATE CONSIDERED		12/05/2007		
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